



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE


Applicant: Masashi GOTO et al.  
Title: DIELECTRIC FILM, ITS FORMATION METHOD,  
SEMICONDUCTOR DEVICE USING THE DIELECTRIC  
FILM AND ITS PRODUCTION METHOD  
Application No.: 10/726,870  
Filing Date: 2 December, 2003  
Examiner/Unit: Dao H. Nguyen / 2818  
Attorney Docket No.: 2204-011-03

**CERTIFICATE OF MAILING**

I hereby certify that this communication, and any document being attached hereto,

☒ is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail addressed to: MS Amendments, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450

on this 15<sup>th</sup> day of September, 2005.



Laura J. Jordan

**RESPONSE TO RESTRICTION REQUIREMENT  
UNDER 37 CFR § 1.143**

TO THE COMMISSIONER FOR PATENTS:

In response to the 23 August 2005 restriction requirement under 35 USC § 121, Applicants elect Group I: Claims 1-5 and 13-17. Please cancel Group II: Claims 6-12 and 18-25, without traverse.

The above response to restriction requirement should place the application in condition for allowance. Applicants respectfully request that a timely Notice of Allowance be issued in this case.

Respectfully submitted,

GRAYBEAL JACKSON HALEY LLP



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